## EV085413637 EV085431692

്റ\ IN THE UNITED	STATES PATENT AND	TRADEMARK OFFICE
JUN 1 3 2003 &	^	09/905 320
Application Serial No  En ing Date	AECE.	July 13, 2001
inventor	UFD	Cem Basceri et al.
Assignee	30N 1.0.22	Micron Technology, Inc.
Group Art Unit		1762
Examiner		Eric B. Fuller
Attorney's Docket No		Ml22-1657
litle: Chemical Vapor	Deposition Methods of	i Forming banum Shomum
Titanate Compris	ing Dielectric Layers, In	cluding Such Layers Having a
	tion of Barium and Stron	

## RESPONSE TO FEBRUARY 13, 2003 OFFICE ACTION

To:

Commissioner for Patents

Washington, D.C. 20231

VIA EXPRESS MAIL

From:

Mark Matkin (Tel. 509-624-276; Fax 509-838-3424)

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Responsive to the Office Action dated February 13, 2003, Applicant

amends and remarks as follows:

## <u>AMENDMENTS</u>